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FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT				ATTY DOCKET NO. 536-009.027		SERIAL NO. To be assigned			
				APPLICANT: Holger RUCKER et al.					
				FILING DATE: Herewith		ART UNIT: To be assigned			
UNITED STATES PATENT DOCUMENTS									
EXAM. INITIAL		DOCUMENT NUMBER	DATE	INVENTOR/ASSIGNEE	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
	US	2002/0117733	Aug. 29, 2002	Michael Farjami, Esq.			Racaneli		
	US	6,642,553	Nov. 4, 2003	Juergen Drews et al.					
	US	2003/0189239	Oct. 9, 2003	Alexander Kalnitsky et al.					
	US	5,523,606	Jun. 4, 1996	Toru Yamazaki					
	US	6,492,238	Dec. 10, 2002	David C. Ahlgren et al.					
FOREIGN PATENT DOCUMENTS									
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO		
	EP	0 418 185 A1	Jul. 31, 1990	EP					
	EP	1 128 422 A1	Aug. 29, 2001	EP					
	EP	0 949 665 A2	Apr. 7, 1999	EP					
OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)									
		H.J. Osten et al., <i>The Effect of Carbon Incorporation on SiGe Heterobipolar Transistor Performance and Process Margin</i> ; IEEE 1997 0-7803-4100 (pages 32.4.1 - 32.4.4).							
Examiner (To be assigned)				Date: 10/20/2009					

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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /L.P./